

<b>Notice of References Cited</b>	Application/Control No. 10/521,025	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Monique R. Jackson	Art Unit 1794	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,494,710	02-2009	Ishihara et al.	428/402
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N	JP 2002216543 A	08-2002	Japan	KAJIMOTO et al.	
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	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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